

**Search Query Case No. 10/650,599**

1	("5633737").PN.	USPAT
465	(fly adj eye adj lens) and ((luminance with adjust\$5) or (distribution with (transmit\$5 or mask\$1)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
75	(fly adj eye adj lens) and ((luminance with adjust\$5) or (distribution with (transmit\$5 or mask\$1))) and collimator\$1	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
131	(fly adj eye adj lens) and ((luminance with adjust\$5) or (distribution with (transmit\$5 or mask\$1))) and (collimator\$1 or (collimat\$3 with lens\$2))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
3	((fly adj eye adj lens) and ((luminance with adjust\$5) or (distribution with (transmit\$5 or mask\$1))) and (collimator\$1 or (collimat\$3 with lens\$2))) and (microlens\$2 with array\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
3	((fly adj eye adj lens) and ((luminance with adjust\$5) or (distribution with (transmit\$5 or mask\$1))) and (collimator\$1 or (collimat\$3 with lens\$2))) and (second with microlens\$2 with array\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
60	method with microlens\$2 with exposure\$1	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
180	method with microlens\$2 with substrate\$1 with (manufactur\$3 or mak\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
8	(method with microlens\$2 with substrate\$1 with (manufactur\$3 or mak\$3)) and 216/\$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
30	(method with microlens\$2 with substrate\$1 with (manufactur\$3 or mak\$3)) and 359/\$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
0	(method with microlens\$2 with substrate\$1 with (manufactur\$3 or mak\$3)) and 355/\$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
6	(method with microlens\$2 with substrate\$1 with (manufactur\$3 or mak\$3)) and 430/\$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
2239	(359/618,619,621,622,754).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB

6279	(355/53,67,71).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
2727	(356/399-401).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
1016	(250/548).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
140	(216/26).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
3281	(430/30,321).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
14475	((359/618,619,621,622,754).CCLS.) or ((355/53,67,71).CCLS.) or ((356/399-401).CCLS.) or ((250/548).CCLS.) or ((216/26).CCLS.) or ((430/30,321).CCLS.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
22	(method with microlens\$2 with substrate\$1 with (manufactur\$3 or mak\$3)) and (((359/618,619,621,622,754).CCLS.) or ((355/53,67,71).CCLS.) or ((356/399-401).CCLS.) or ((250/548).CCLS.) or ((216/26).CCLS.) or ((430/30,321).CCLS.))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB

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US 20040008417 A1	US-PGPUB	System and method for providing a substrate having micro-lenses	359/619
US 6330112 B1	USPAT	Optical modulator and image projection display apparatus	359/621
US 5079130 A	USPAT	Partially or fully recessed microlens fabrication	430/321
US 20020027715 A1	US-PGPUB	System and method for providing a substrate having micro-lenses	359/619
US 5867321 A	USPAT	Planar microlens array and method of making same	359/619
US 5982552 A	USPAT	Planar microlens array having high converging efficiency	359/620
US 20040051977 A1	US-PGPUB	Exposing apparatus and exposing method for microlens array	359/754
US 20040099633 A1	US-PGPUB	Method of manufacturing microlens substrate, and microlens exposure optical system	216/26
US 5370768 A	USPAT	Method for making microstructures	216/26
US 5718830 A	USPAT	Method for making microlenses	216/26
US 6469832 B2	USPAT	Method for manufacturing microlens substrate, microlens substrate, opposing substrate for liquid crystal panel, liquid crystal panel, and projection display apparatus	359/619
US 6558878 B1	USPAT	Microlens manufacturing method	430/321
US 20030108821 A1	US-PGPUB	Microlens array fabrication	430/321
US 5633737 A	USPAT	Projection-type color liquid crystal display having two micro-lens arrays	349/95